

Supplementary

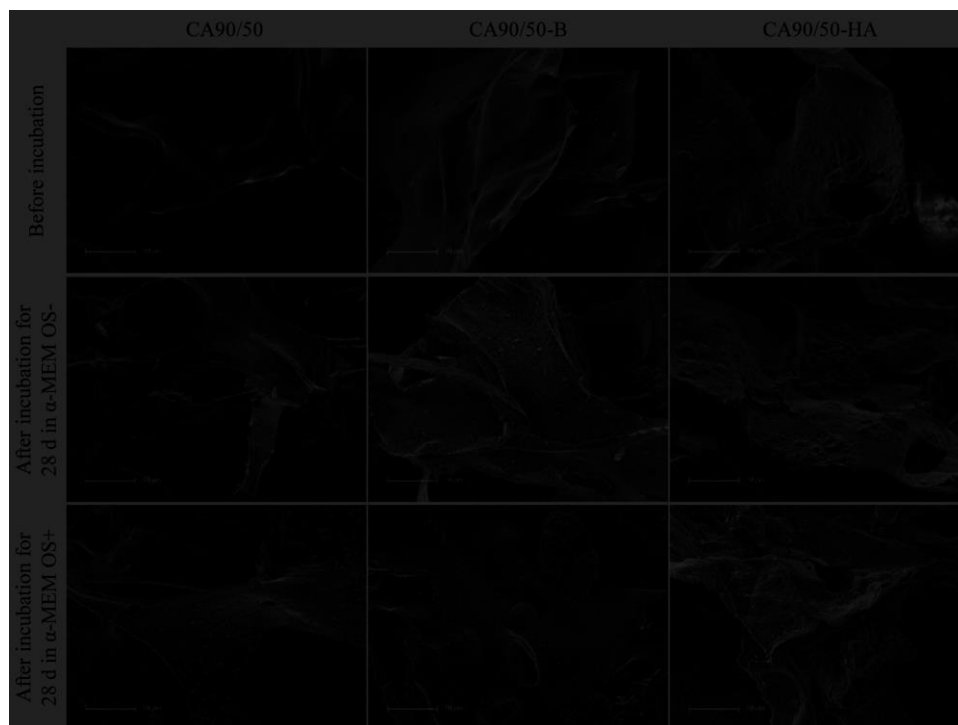


Figure S1 Scanning electron micrographs of plain as well as brushite and hydroxyapatite modified chitosan scaffolds, respectively. Secondary electron images were taken at 3 keV with an XL30ESEM-FEG (FEI).